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# **Retrieving 3D Information for Probe Microscopy**

A displacement sensor that employs an electromagnetic radiation source that generates a beam of electromagnetic radiation for measuring a feature of an object

Georgia Tech inventors have created a displacement sensor that employs an electromagnetic radiation source that generates a beam of electromagnetic radiation for measuring a feature of an object. The displacement sensor includes a displacement probe, a multi-dimensional diffraction grating, and a plurality of photon detectors. A reflection surface, which is changed when the probe interacts with the object, interacts with the beam from the electromagnetic radiation source and reflects a beam from the reflection surface. The multi-dimensional diffraction grating interacts with the reflected beam and generates a pattern of diffracted beams. Each photon detector senses a different diffracted beam, thereby providing information about the state of the probe.

# **Summary Bullets**

- Can isolate the central region of a diffraction spot from its respective fringes
- Creates ideal diffraction patterns

#### Solution Advantages

- Can isolate the central region of a diffraction spot from its respective fringes
- Creates ideal diffraction patterns

### Potential Commercial Applications

Commercial probe microscopes

#### **Background and More Information**

Beam deflection is the most common detection method used in modern commercial probe microscopes because of its simplicity and versatility. Traditionally, beam deflection requires a force-sensing structure, probe tip, light source, and photodetector. A recent modification to the beam-deflection method is to insert a diffraction grating into the path of the beam and measure angular displacement of diffraction spots rather than angular displacement of the reflected incident beam.

#### **Inventors**

- Dr. Zhong Wang
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  Distinguished Professor Georgia Tech College of Engineering
- Brent Buchine Graduate Student - Georgia Tech School of Materials Science and Engineering
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# **IP Status**

: US7808656B2

#### **Publications**

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# **Images**

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